Automatic

## Four-Point Probe Model 280I Series



Model 280SI



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FOUR DIMENSIONS INC.

## Many Models to Meet Your Budget and Measurement Needs

# **280PI** This is the most basic model in this series. It can automatically measure 1, 5, and 9 sites and then print the measured data, mean, and range on a 2 1/4 inch tape. The measurement range is $1m\Omega/sq$ . to 800 k $\Omega/sq$ .

**280PCI** It has the function of 280PI plus ability to display in V/I, ohm-cm, and standard deviation. It stores up to 15 user-defined measurement programs and comes with a small external computer with keypad and LCD display.

**280SI** This model is PC controlled with Windows based powerful software which includes operation administration, recipe set-up, Librarian data storage, increased storage capacity, contour and 3D mapping, trend charts, P-N type detection, SECS-II, diagnostics, and many other convenient features.

**280TS** It has the same function as 280SI plus temperature compensation.

**280TC** It has the same function as 280TSI, in addition, it has Statistical Process Control (SPC)

**280DI** It has the same function as 280SI, but with an extended measurement range up to 8E9  $\Omega$ /sq., or 8E11  $\Omega$ /sq..

**280HCI** It has the same function as 280TCI plus an easily controllable hot chuck and high temperature chamber.

### **Other Four-Point Probe Series:**

120 Series.....Manual Four-Point Probe for Wafers, Ingots and Slugs
233AC....Four-Point Probe System for up to 200mm Wafers with C2C Handling Capability
300 Series...Including Models 300, 333A, 333AC and 333AF for Mapping and/or C2C Handling of 300mm Wafers
680I Series...Sheet Resistivity Mapping System for Compound Semiconductors such as GaAs and SiC
1100I Series...Sheet Resistivity Mapping for Flat Panels Model 233AC



## Options to Fulfill Various Measurement Requirements

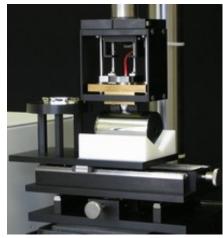
- Tests High-Resistivity thick Si Substrate
- Tests Wafer Within 0.3°C of Room Temperature (Temperature compensation option available for the case of unstable room temperatures.)
- Measure Resistivity in wide Temperature range, Features Room Temperature to 100 °C within 0.5°C Temperature Uniformity
- SECS II Communication
- Statistical Process Control
- Adopting Solar Cell Sized Wafers

## Windows Based Powerful Software

- Convenience of Windows
- Friendly User-Interface
- Data Storage for Millions of Data Sets
- Librarian Data Searching Program for Quick and Easy Retrieval
- LAN, Excel & Many Other Great Features !
- Individual Site Multiplier
- Measurement Unit Conversion from the stored data

- Site Dependent Geometric Correction
- Detecting P-N Type
- Cartesian-Arrayed Mapping
- Polar Coordinated Mapping
- Diameter Scan
- Custom Test Sites
- Automatic Thickness Compensation
- Thin Metal Film Corrections
- Personalized Recipe Options

## Reliable and Easy to Maintain



A probe stage for Model 120

- Capable of Making Measurements without Computer
- Standard Resistor Network and Firmware Allowing Easy and Quick Electronic Calibration
- Assembled with Easily Replaceable Modules
- Optional Trouble Shooting Kits Available for Quick and Easy On-Site Trouble Shooting
- Diagnostic Program Available for Hardware and Software
- Low Price Precision Durable Probe Head

Systems installed worldwide exceeding MTBF of 5,000 hours

### **Specifications**

#### **Measurement**

Wafer Sizes Accommodated **Test Diameter** Quick-Checks

Cartesian Maps Polar Map Site Number **Diameter Scans** Measurement Range Measurement Units Measurement Repeatability **Electronic Accuracy Current Resolution Compliance Voltage for Measurement**  50, 75, 100, 125, 200 (mm) Up to 3mm from wafer edge 1, 5, 9 sites, 5, 6, 9, 10, 13 site ASTM/SEMI X-patterns or custom sites Any site-interval  $\geq 0.1$  mm, up to 6000 sites 9,25,45,49,65,81,121,169,225,289,361,441,529,625 Any site interval to nearest mm  $1m\Omega/sq.$  to  $800k\Omega/sq.$  or  $8E9 \Omega/sq.$  $\Omega$ /sq., Ω-cm, V/I, μ [T], Å[T] <0.2% (typical) <0.1% (precision resistor) 16 Bit A/D 125V

#### Computer System

Computer Type Monitor Type Printer Type Data Transfer

Windows Based PC LCD-FPD HP Color Deskjet RS232, SECS I, II

#### Analysis Capabilities: Automap Model 280I Software under Windows

- Color Contour Map
- 3D Surface Map
- P/N Type Testing
- Bulk Resistivity Measurement

#### **Facility Requirements**

Power Vacuum **Tabletop Footprint**  • Diameter Scan

- Partial Wafer
- Numerical Data Printout
- Data Transfer to Spread Sheet
- Statistical Process Control (SPC)
- Measurement Data Comparison
- Thickness, Temperature and Edge Correction
- Trend Chart, by Wafer/Day/Month

100/115/230VAC, 50/60Hz, 200W 20 in. Hg 21.5" depth x 20" width x 25" height

#### **Probes**

Probe Spacing Probe Force Range	1mm (Standard) 90g –180g (Standard) other ranges available		
Туре	Tip Radius (µ)	Material	Application
А	25	WC	Bulk, Thick Epi, Metals
В	100	WC	General
Μ	300	WC	Implant, Diffusion,
Ν	500	WC	Shallow Implant, Thin Epi

